



**PATENT APPLICATION**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Fumio KOYAMA et al.

Group Art Unit: 2828

Application No.: 10/026,637

Examiner: A. Rodriguez

Filed: December 27, 2001

Docket No.: 111587

For: SURFACE EMITTING SEMICONDUCTOR LASER AND MANUFACTURING  
METHOD THEREOF

**AMENDMENT UNDER 37 C.F.R. §1.111**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In reply to the April 7, 2005 Office Action, and further to the July 14, 2005 personal interview with Examiner Rodriguez, please consider the following:

**Amendments to the Claims** as reflected in the listing of claims; and

**Remarks.**